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Dated: 3/28/08 Signature: KMT
(Keith M. Tackett)

Docket No.: APPM/008657/DISPLAY/AKT/RKK
1016.012168
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Soo Young Choi et al.

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§ Group Art Unit: 1792

Serial No.: 10/823,347

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Examiner: S. Chandra

Confirmation No.: 4736

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Filed: April 12, 2004

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For: GAS DIFFUSION
SHOWER HEAD DESIGN FOR
LARGE AREA PLASMA ENHANCED
CHEMICAL VAPOR DEPOSITION

AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated March 6, 2008, finally rejecting claims 23-48, please amend the above-identified U.S. patent application as follows:

Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/APPM/008657/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. **Remarks** begin on page 6 of this paper.